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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re the Application of:

Yuichiro Shindo et al.

Application No.:

Corresponding International Filing No.:

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Examiner:

Group Art Unit:

Mail Stop PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**FIRST PRELIMINARY AMENDMENT**

Sir:

**Before calculating the filing fee**, please amend the above-identified patent application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page two of this paper.

**Remarks** begin on page three of this paper.